



SHEET 1 OF 1

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 220212US2	SERIAL NO. 10/084,221	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Kazuya OHUCHI		
		FILING DATE February 28, 2002		GROUP 2815		
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	AA					
	AB					
	AC					
	AD					
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	AJ					
	AK					
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	AN					
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO	
	AO					
	AP					
	AQ					
	AR					
	AS					
	AT					
	AU					
	AV					
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)						
JN	AW	T.-J. KING, et al., IEEE Transactions on Electron Devices, vol. 41, no. 2, pps. 228-232, "ELECTRICAL PROPERTIES OF HEAVILY DOPED POLYCRYSTALLINE SILICON-GERMANIUM FILMS", February 1994				
	AX					
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	AZ					
Examiner	JOSEPH NVYEN			Date Considered	RECEIVED TECHNOLOGY CENTER 2000 JUN 18 2002	
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						